



2877

Atty Ref: PAS-202-A

**INTRODUCTORY COMMENTS**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tae Bong Eom

Serial No: 10/051,375

Filed: 01/17/2002

Examiner: Michael A. Lyons

Group Art Unit: 2877

Title: NONLINEARITY ERROR CORRECTING METHOD AND PHASE  
ANGLE MEASURING METHOD FOR DISPLACEMENT  
MEASUREMENT IN TWO-FREQUENCY LASER INTERFEROMETER  
AND DISPLACEMENT MEASUREMENT SYSTEM USING THE SAME

**AMENDMENT-A**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 3, 2003, please amend the above-identified patent application as follows, and favorably consider the accompanying remarks.

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SEP 11 2003  
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